

Notice of References Cited		Application/Control No. 09/975,256	Applicant(s)/Patent Under Reexamination RAMKUMAR ET AL.	
		Examiner David L. Hogans	Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,766,994	06-1998	Tseng, Horng-Huei	438/254
	C	US-6,399,520	06-2002	Kawakami et al.	438/778
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peter van Zant; Microchip Fabrication, 2000; McGraw-Hill; Fourth Edition; pages 156, 160, 188-9, 503 and 513-4.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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